

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No. 029567-00011

In re patent application of:

Makiko KITAZOE, et al.

Confirmation No.: 8995

Serial No.: 10/593444

Art Unit: 1792

Filed: February 5, 2007

Examiner: Joseph Albert MILLER, Jr.

For: UNIT-LAYER POST-PROCESSING CATALYST CHEMICAL-VAPOR
DEPOSITION APPARATUS AND ITS FILM FORMING METHOD

RESPONSE UNDER 37 C.F.R. §1.111

Mail Stop AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

August 4, 2009

Sir:

In reply to the outstanding Office Action dated March 5, 2009, please amend the application as shown on the following pages. The period for response is extended two (2) months, from June 5, 2009 to August 5, 2009. The two month extension of time fee is being submitted herewith via EFS.

Amendments to the Specification begin on page 2.

Amendments to the Claims begin on page 7.

Remarks begin on page 12.

Conclusion begins on page 17.